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In re application of
Cohen et al.
Serial No. 09/206,027
Filed: December 4, 1998
For: PLASMA PRECLEAN WITH ARGON
HELIUM AND HYDROGEN GASES

DECISION ON
PETITION

This is a response to the PETITION UNDER 37 C.F.R. §1.181 TO WITHDRAW HOLDING OF ABANDONMENT filed March 11, 2004. The petition requests that the abandonment, as set forth in the Notice of Abandonment of February 26, 2004, for failure to timely file a proper reply to the Office letter of March 19, 2003 be withdrawn since the applicants did timely file a response thereto on June 19, 2003 by facsimile transmission to the USPTO. (A copy of the papers filed June 19, 2003 and a copy of the Facsimile Transmission Report indicating receipt of the facsimile transmission at the USPTO is attached to the instant petition.)

DECISION

The instant request has been accepted as a petition to withdraw the holding of abandonment under the provisions of 37 CFR 1.181 (no fee) - no abandonment-in-fact. A review of the evidence presented reveals that applicant's response was properly filed on June 19, 2003 by facsimile transmission as evidenced by the properly completed Certification of Facsimile Transmission attached to applicant's response and by the copy of the Facsimile Transmission report provided with the instant petition which indicates the successful transmission, to a USPTO facsimile telephone number (703-872-9310), of 14 pages. Therefore, the application was never in-fact abandoned and any holding of abandonment for failure to timely file a proper response to the Office letter mailed on June 19, 2003 is hereby vacated, and the application is returned to pending status.

The application shall be forwarded to the examiner for processing and consideration of the papers originally filed June 19, 2003 by facsimile transmission and a copy of which is provided as an attachment to the instant petition.

The Petition is **GRANTED**.

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